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PTO/SB/08a (08-03)
Approved for use through 07/31/2008. OMB 0851-0031
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Under the Paperwork Reduction Act of 1995 Complete if Known Substitute for form 1449A/PTO **Application Number** 10/702,049 Filing Date INFORMATION DISCLOSURE 11/06/2003 First Named Inventor STATEMENT BY APPLICANT **NORIAKI FUKIAGE** 1763 Examiner Name (Use as many sheets as necessary) Attorney Docket Number 071469-0305918 Sheet of

Examiner Initials*	Cite No. <sup>1</sup>	Document Number  Number-Kind Code <sup>2 (Vknown)</sup>		Publication Date	Name of Patentee or	Pages, Columns, Unes, Where	
				MM-DD-YYYY	Applicant of Cited Document	Relevant Passages or Relevant Figures Appear	
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Examiner Initials*	Cite No.	Foreign Patent Document  Country Code <sup>3</sup> Number *Nind Code <sup>6</sup> (# known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Τ <sup>α</sup>	
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Examiner Signature	/Tabassom Tadayyon Eslami/	Date Considered	09/19/07	

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Substitute for fo	m 1449B/PTO	•		Complete if Known			
			<u>-</u> -	Application Number	10/702,049		
	MATION I			Filing Date	11/06/2003		
STATE	MENT BY	APPLIC	CANT	First Named Inventor	NORIAKI FUKIAGE		
				Art Unit	1763		
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Sheet	1	of	1	Attorney Docket Number	071469-0305918		

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Examiner Signature	/Tabassom Tadayyon Eslami/	Date	09/19/07
Signature		Considered	

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